

Notice of References Cited	Application/Control No. 10/761,190	Applicant(s)/Patent Under Reexamination KIM, KUN-TAE	
	Examiner JASON K. LIN	Art Unit 2623	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2001/0021998	09-2001	Margulis, Neal	725/81
*	B	US-2003/0046696	03-2003	Mizuno et al.	725/46
*	C	US-6,704,060	03-2004	Levandowski, Mark C.	348/725
*	D	US-7,222,353	05-2007	Forler, Joseph Wayne	725/27
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.